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			Filing Date	Herewith	
			First Named Inventor	Chang, et al.	
			Art Unit	TBD	
			Examiner Name	TBD	
Sheet	1	of	1	Attorney Docket Number	TSM02-0658

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
[Signature]	A	US-3,677,634	07-18-1972	Mathisen	
	B	US-3,712,813	01-23-1973	Ross, et al.	
	C	US-4,734,345	03-29-1988	Nomura, et al.	
	D	US-4,857,425	08-15-1989	Phillips	
	E	US-4,868,428	10-30-1990	Phillips	
	F	US-5,187,372	02-16-1993	Clube	
	G	US-5,504,598	04-02-1998	Goto, et al.	
	H	US-5,528,390	08-18-1998	Goto, et al.	
	I	US-5,774,240	08-30-1998	Goto, et al.	
		US-			
		US-			
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
[Signature]	J	DT-1 331 076	09-19-1973	SIEMENS		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
[Signature]	K	WOLF, STANLEY, Ph.D. and TAUBER, RICHARD N., Ph.D.; Silicon Processing for the VLSI Era, 2000; pp. 615-635; Volume 1: Process Technology Second Edition; Lattice Press, Sunset Beach, California.	
[Signature]	L	MÜTZEL, MARIO; "Building 3D Nanostructures with Holograms"; STP-Gateway; April 3, 2002; http://www.stp-gateway.de/Archiv/archiv475-e.html	
[Signature]	M	MARDER, SETH, et al.; "Materials Absorb Two Photons, Generate Acid on Cue"; UniSci Daily University Science News; May 13, 2002; http://unisci.com/stories/20022/0513023.htm	
[Signature]	N	STILES, LORI; "Cornell Researchers Collaborate on a Major Advance in Microfabrication"; Cornell Chronicle; May 16, 2002; http://www.news.cornell.edu/Chronicle/02/5.16.02/Ober-3D_fab.html	

Examiner Signature	[Signature]	Date Considered	12/06
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